

Notice of References Cited

Application/Control No.

09/646,139

Applicant(s)/Patent Under

Reexamination

ISHIDA ET AL.

Examiner

Holly Rickman

Art Unit

1773

Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6347016B1	07-1998	Ishida et al.	360/17
	C	US-			
	D	US-			
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	F	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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